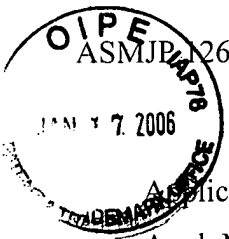


AF
JFW

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shimizu, et al.
Appl. No. : 10/618,900
Filed : July 14, 2003
For : SINGLE-WAFER-PROCESSING
TYPE CVD APPARATUS
Examiner : Rudy Zervigon
Group Art Unit : 1763

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 11, 2006

(Date)

Katsuhiro Arai, Reg. No. 43,315

AMENDMENT AFTER FINAL

Mail Stop: AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed November 1, 2006, please reconsider the present application in light of the following amendments and comments.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.